

<b>Notice of References Cited</b>	Application/Control No. 10/825,199	Applicant(s)/Patent Under Reexamination JEONG et al.	
	Examiner Lee, Calvin	Art Unit 2818	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	C	US-			
	D	US-			
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	F	US-			
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	J	US-			
	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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